

Supporting Information for:

Creation of a Superhydrophobic Surface from a Sublimed Smectic Liquid Crystal

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ESI, Figure S1§

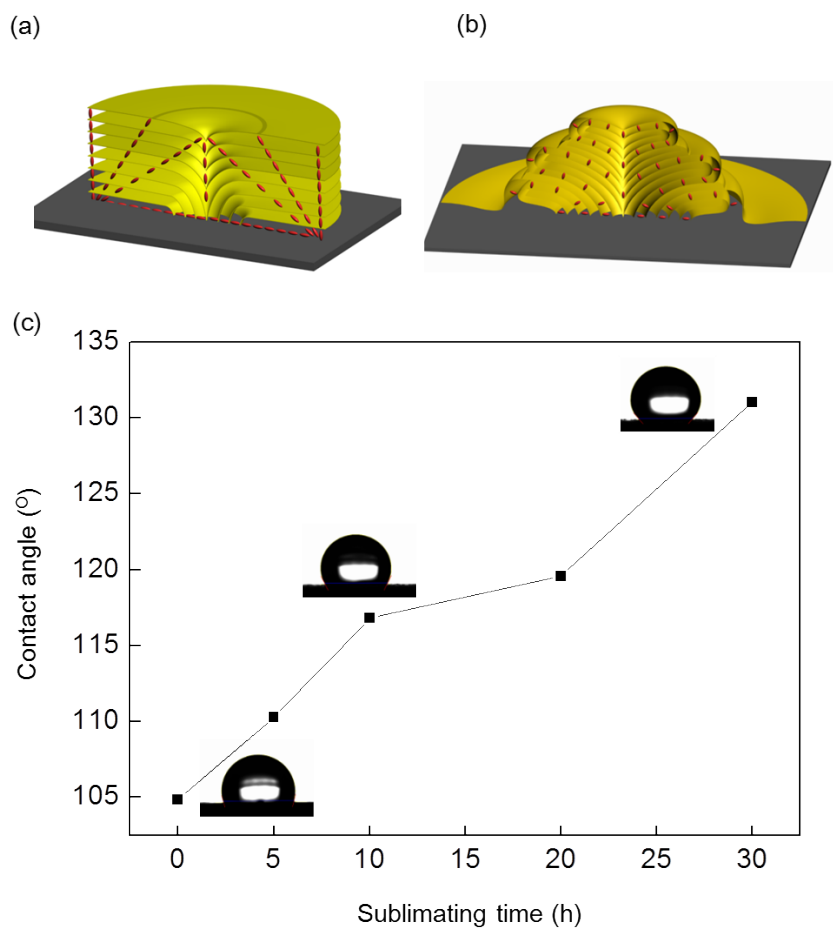


Fig. S1 (a, b) The schematic illustrations of single TFCD and its sublimed TFCD. (c) CA measurements of water droplets on sublimed TFCD arrays on a flat Si substrate as a function of sublimating time.

ESI, Figure S2§

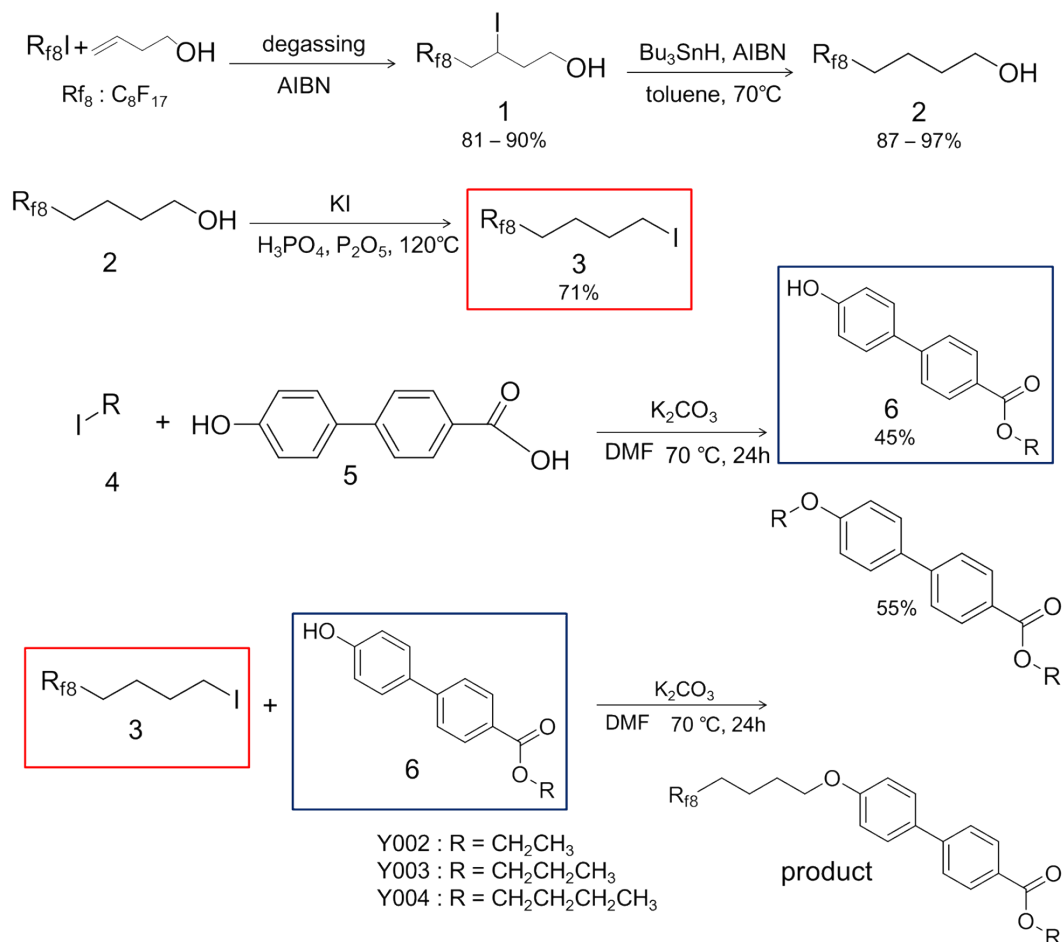


Fig. S2 Semi-fluorinated liquid crystalline materials **Y002**, **Y003**, and **Y004** were synthesized by the procedure used for the alkylation of ethyl, propyl, and butyl 4'-hydroxy-4-biphenyl carboxylate with 1H,1H,2H,2H,3H,3H,4H,4H-perfluorododecyl iodide in DMF at 70°C under reflux with K₂CO₃.¹⁵

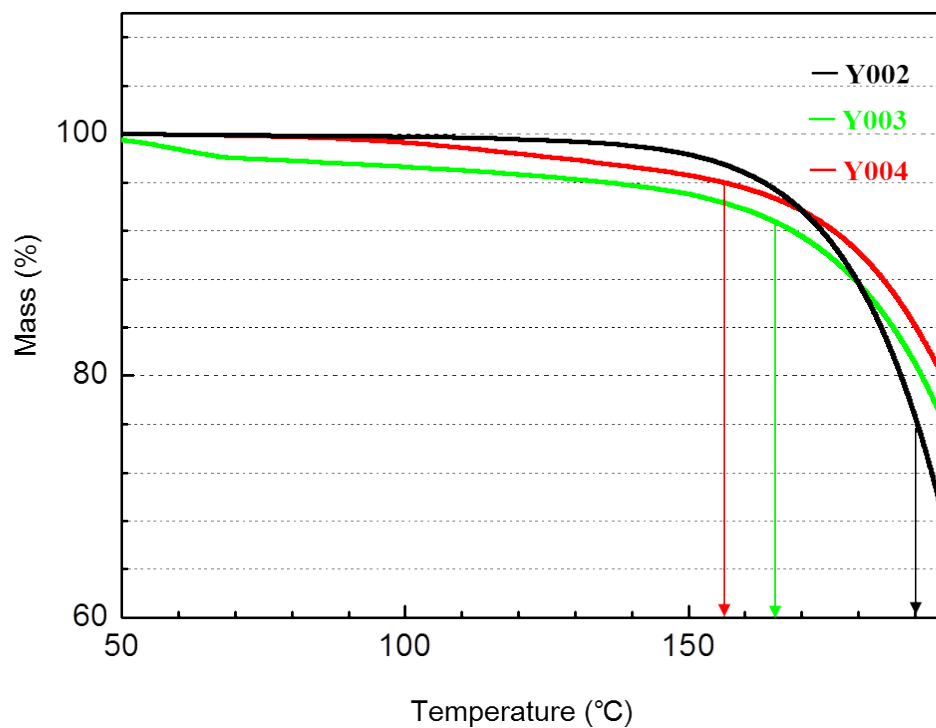


Fig. S3 Thermogravimetric (TGA) results of **Y002**, **Y003**, and **Y004** during cooling (cooling rate: $1^{\circ}\text{C min}^{-1}$) shows that sublimation occurred before the material reached their respective isotropic temperatures. The arrows indicate the respective isotropic temperature of each material.

ESI, Figure S4§

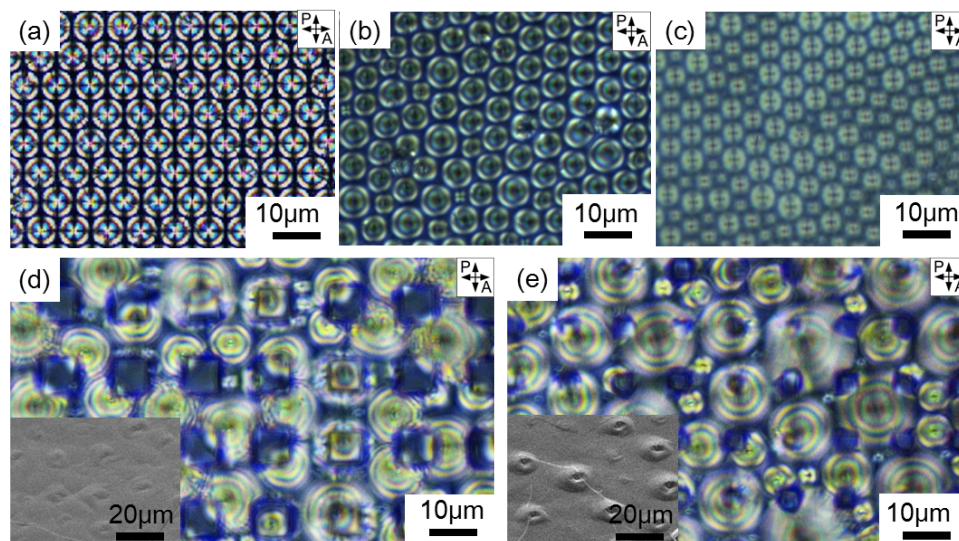


Fig. S4 DRLM images of: (a-c) normal TFCDs of **Y002-Y004** on planar anchoring substrates. (d-e) epitaxially-assembled TFCDs of **Y002** on square-pillar arrays with $l = 10 \mu\text{m}$ and $l = 5 \mu\text{m}$, respectively. Insets of (d, e) are corresponding SEM micrographs.

ESI, Figure S5§

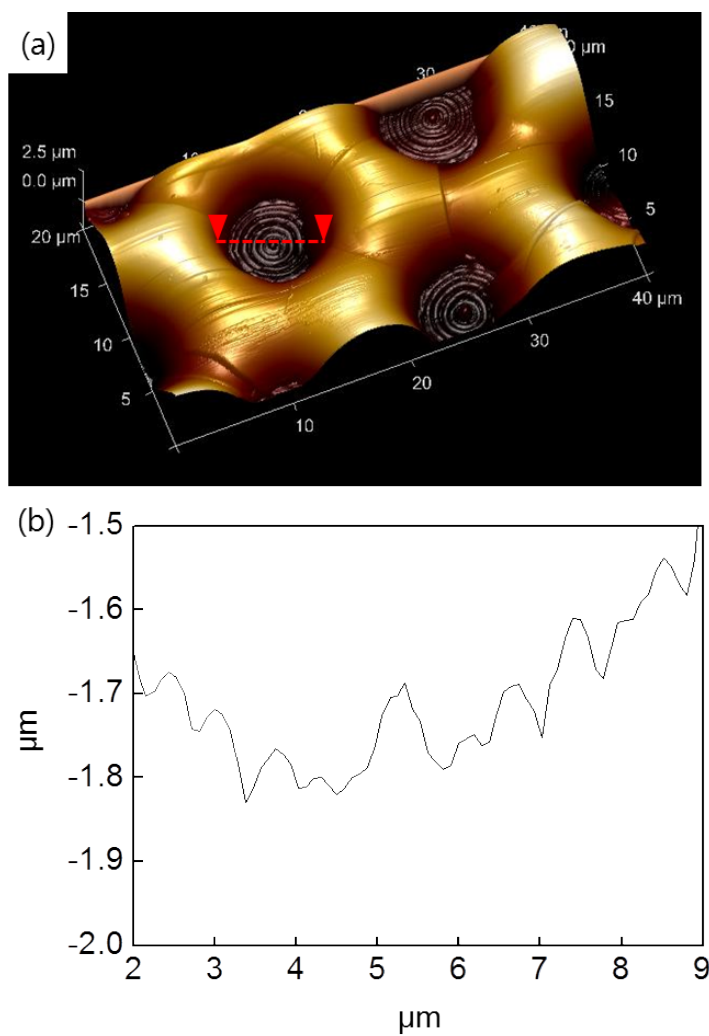


Fig. S5 (a-b) AFM image and height profile of circular hemi-cylinders in single TFCD on a flat Si substrate.

ESI, Figure S6§

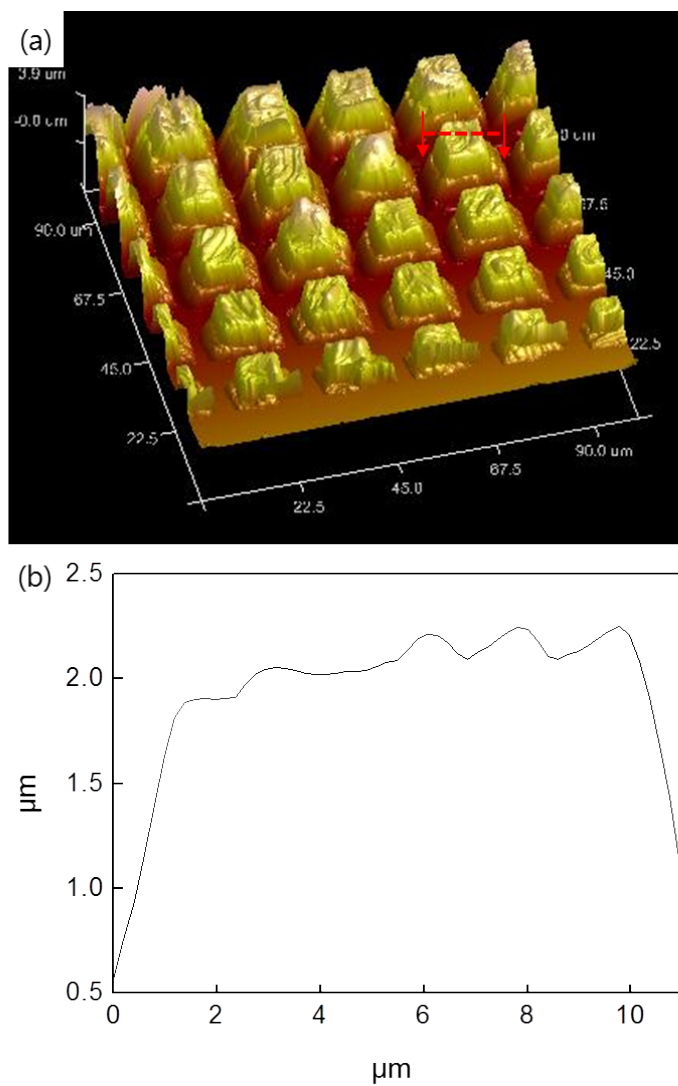


Fig. S6 (a-b) AFM images and height profile of hemi-cylinders with TFCDs on pillar arrays ($l=10 \mu\text{m}$).

ESI, Figure S7§

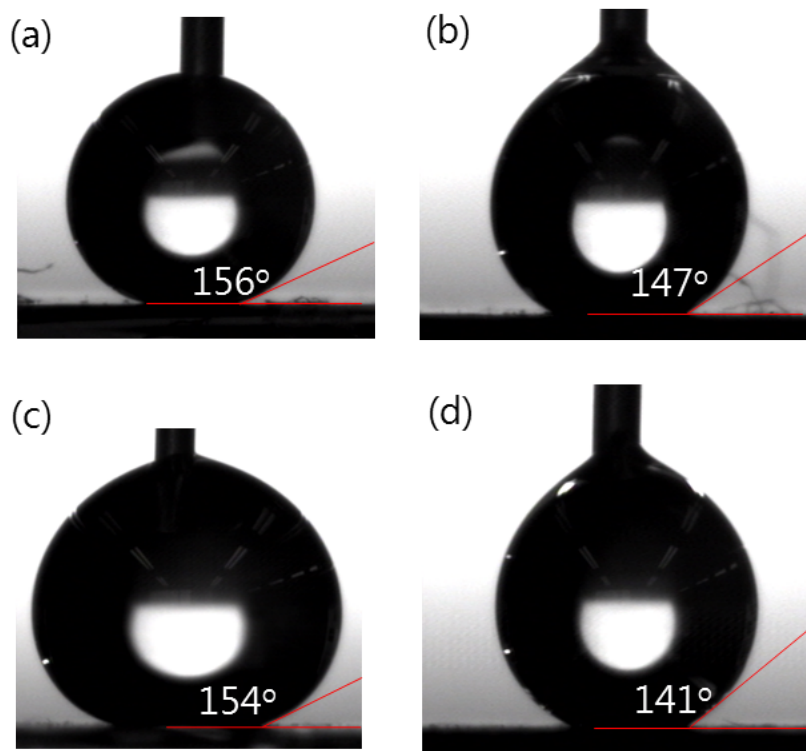


Fig. S7 CA hysteresis. The advancing angle and receding angle of a water droplet on the sublimed TF CDs on pillar patterns. (a, b) for $l = 10 \mu\text{m}$ and (c, d) for $l = 5 \mu\text{m}$.

ESI, Figure S8

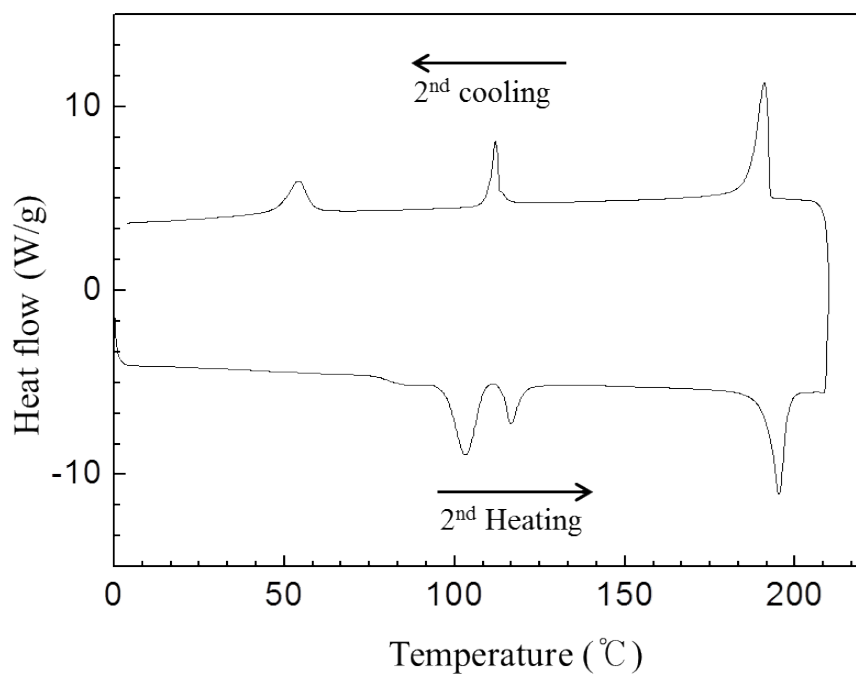


Fig. S8 DSC thermograms for 2nd heating and 2nd cooling cycles for **Y002**. The temperature scan rate was 10°C/min and N₂ purged into the sample chamber (50mL/min).